

Electronic Patent Application Fee Transmittal

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| Application Number: | 10750021 |
| Filing Date: | 30-Dec-2003 |
| Title of Invention: | Method for fabricating semiconductor device having trench type device isolation layer |
| First Named Inventor/Applicant Name: | Tae-Woo Jung |
| Filer: | Stacie Jo Sundquist/Si Vuong |
| Attorney Docket Number: | 51876P542 |

Filed as Large Entity

Utility Filing Fees

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
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Basic Filing:

Pages:

Claims:

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|------------------------|------|---|----|-----|
| Claims in excess of 20 | 1202 | 5 | 50 | 250 |
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Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|------------------------------------|----------|----------|--------|----------------------|
| Extension - 3 months with \$0 paid | 1253 | 1 | 1020 | 1020 |
| Miscellaneous: | | | | |
| Total in USD (\$) | | | | 1270 |